

1763

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Applicant(s): **GEUN-YOUNG YEOM**

Docket No.

HNE-0003

Serial No.

10/086,497

Filing Date

February 28, 2002

Examiner

Alejandro Mulero, Luz L.

Group Art Unit

1763

Invention: **LAYER-BY-LAYER ETCHING APPARATUS USING NEUTRAL BEAM AND ETCHING METHOD USING THE SAME**

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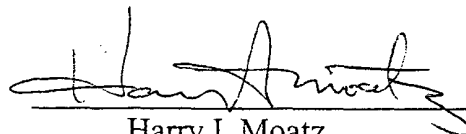
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APPLICANT: GEUN-YOUNG YEOM)
SERIAL NO.: 10/086,497)
FILED: February 28, 2002)
FOR: LAYER-BY-LAYER ETCHING APPARATUS)
USING NEUTRAL BEAM AND)
ETCHING METHOD USING THE SAME)

GROUP 1700

) Group Art No.:

) 1763

) Examiner:

) Alejandro

) Mulero, Luz L.

RESPONSE TO RESTRICTION REQUIREMENT WITH AMENDMENT,
PURSUANT TO 37 C.F.R. §1.111

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a response to an office action dated April 10, 2003, wherein the Examiner has subjected claims 1-21 to a restriction requirement. Consideration of this response and examination on the merits is respectfully requested.